OIP Reventor:

Brent A. McClure et al.

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Capacitor Constructions and Methods of Forming

anee:

Micron Technology, Inc.

Serial No.: 10/624,340

Filed:

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INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. No admission is made regarding whether the listed reference is prior art.

Citation of this reference is respectfully requested.

Respectfully submitted,

Dated: _ 21 Nov 2007

By:

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